Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	362	(324/207.15).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	OFF	2005/09/30 11:33
L2	637	((324/229) or (324/230)).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	OFF	2005/09/30 11:33
L3	4	1 and 2	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 11:34
L4	2263	((324/207.23) or (324/207.24) or (324/207.25)).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	OFF	2005/09/30 11:34
L5	791	4 and (optic optical reflect\$6 irradiat\$4 light laser lamp radiat\$4 uv ultraviolet refract\$6 illumin\$4 spectr\$4 ellipsometry spectrograph ccd strobe)	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 11:37
L6	74	4 and (optic optical reflect\$6 irradiat\$4 light laser lamp radiat\$4 uv ultraviolet refract\$6 illumin\$4 spectr\$4 ellipsometry spectrograph ccd strobe).ab.	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 11:47
L7	786	(356/630-632).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM TDB	OR	OFF	2005/09/30 11:47
L8	0	4 and 7	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 11:47
L9	667	7 and (eddy induct\$5 resistance magnetic field electromagnetic coil current induced induce induces inductance)	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 11:48
L10	. 62	7 and (eddy induct\$5 resistance magnetic field electromagnetic coil current induced induce induces inductance).ab.	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 11:48
S2	1216803	(sens\$4 probe determin\$4 measur\$4 calculat\$ comput\$4) with (eddy induct\$5 resistance noncontact contactless non-contact field electromagnetic coil current induced induce induces inductance)	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 11:35

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S3	326170	cmp planariz\$6 polish\$4	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/29 17:26
S4 .	43032	S2 and S3	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/29 17:26
S5	1480337	(sens\$4 probe detect\$4 determin\$4 measur\$4 calculat\$ comput\$4) with (eddy induct\$5 resistance noncontact contactless non-contact field electromagnetic coil current induced induce induces inductance)	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 11:47
S6	6170	S3 same S5	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/29 17:27
S7	111505	"156"/\$.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/29 17:27
S9 .	373834	"216"/\$.ccls. "438"/\$.ccls. "118"/\$.ccls. "427"/\$.ccls. "438"/\$.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/29 17:28
S10	293515	"250"/\$.ccls. "356"/\$.ccls. "324"/\$.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/29 17:28
S11	759830	S7 S9 S10	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/29 17:28
S12	1701	S6 and S11	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/29 17:29
S13	156	S12 and eddy	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/29 17:29

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	60	(optic\$4 near1 sensor) same (eddy near1 sensor)	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 13:18
L2	295	(optic\$4 near1 sensor) same (eddy)	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM TDB	OR	ON	2005/09/30 13:10
L3	235	2 not 1	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30:13:11
L4	13	2 same (scan\$4 sweep\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 13:12
L8	. 60	(optic\$4 near1 sensor) same (eddy near1 sensor)	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30:13:19
L12	6189	(eddy) same (optic optical reflect\$6 irradiat\$4 light laser lamp radiat\$4 uv ultraviolet refract\$6 illumin\$4 spectr\$4 ellipsometry spectrograph ccd strobe)	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 13:27
L13		12 same arm	US-PGPUB; USPAT; EPO; IPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 13:23
L14	28	13 same (scan\$4 sweep\$4 arc path)	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 13:29
L15	1216803	(sens\$4 probe determin\$4 measur\$4 calculat\$ comput\$4) with (eddy induct\$5 resistance noncontact contactless non-contact field electromagnetic coil current induced induce induces inductance)	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 13:26
L16	236624	15 same (optic optical reflect\$6 irradiat\$4 light laser lamp radiat\$4 uv ultraviolet refract\$6 illumin\$4 spectr\$4 ellipsometry spectrograph ccd strobe)	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 13:28
L17	3072	16 same arm	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 13:28

L19	606	17 same (scan\$4 sweep\$4 arc path)	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 13:29
L20	598	19 not 14	US-PGPUB; USPAT; EPO, JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 13:29
L21	393	20 and (semiconductor wafer ic circuit cmp planariz\$6 polish\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 13:39
L22	311	integrated with sensor with arm	US-PGPUB; USPAT; EPO; IPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 13:40
L23	12	20 and 22	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	ON	2005/09/30 13:40